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54 **Molecular processes and apparatus therefore.**

57 A method for effecting the initiation of a molecular process or reaction in a substance, which comprises bringing the substance into contact with a surface of a cold cathode device and applying an electric potential across the cold cathode device to cause electrons to be emitted from the surface thereof with an energy level sufficient to effect the initiation.

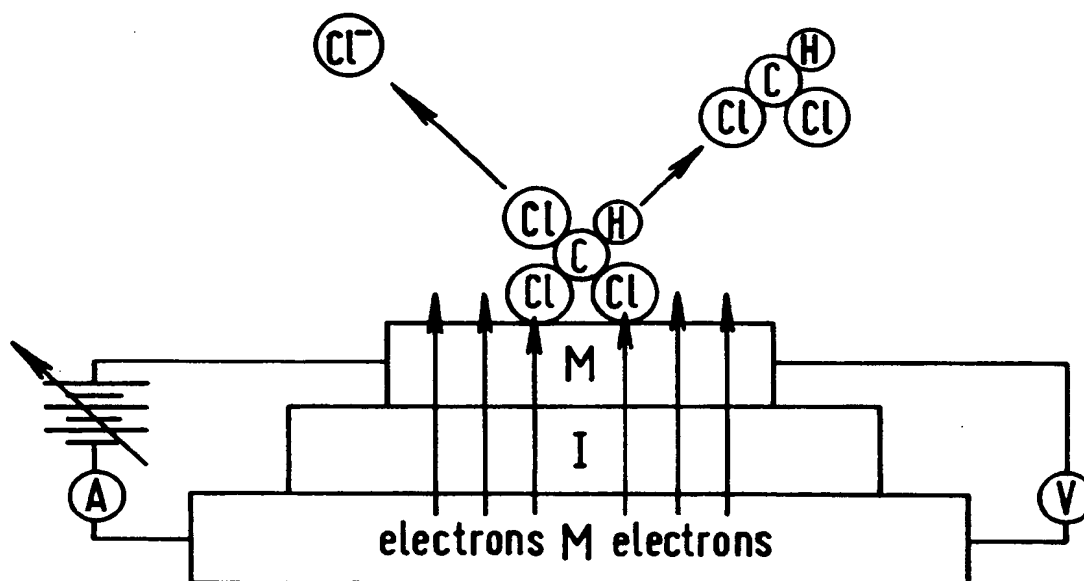


FIG. 1.

This invention relates to a method and apparatus for effecting the initiation of molecular processes in substances present on the surface of the apparatus.

The initiation or catalysis of molecular processes or reactions can be conducted by a variety of means and many ways of effecting them are known.

The present invention is concerned with the provision of a novel means of effecting the initiation and/or catalysis of molecular processes by means of the bombardment of molecules by electrons emitted from a particular type of source, which means it allows for good control of the energy of the electrons during the bombardment.

In accordance with the invention, there is provided a method for effecting the initiation of a molecular process or reaction in a substance, which comprises bringing the substance into contact with a surface of a cold cathode device and applying an electric potential across the cold cathode device to cause electrons to be emitted from the surface thereof with an energy level sufficient to effect the initiation.

The term "cold cathode" is well known in the electronics art and can be simply defined as a device incorporating an electrode from which electron emission is caused by a high potential gradient across the cold cathode device at normal temperatures, for example, those less than 100°C and commonly ambient temperatures.

Examples of cold cathodes are:

- i) "Tip emitters" - which are generally made from a number of silicon or tungsten cones.
- ii) "Back-biased junction cold cathodes" - in which electrons are accelerated across a p-n junction near its surface and emitted into vacuum allowing high electron emission densities.
- iii) "metal-insulator-metal (MIM) devices" - in which a thin sandwich of an insulating material layer is prepared between two metal layers of the same or different metals.

Cold cathodes generally, and in particular each of the above types of cold cathode device can be operated through the application of, and control of, a voltage across the devices. Control of the voltage is critical to ensure that electrons emitted from the device have the correct level of kinetic energy in particular to effect initiation of the desired molecular process in the substance in contact with the device.

Although each of the above types of cold cathode may be employed in the method of the invention, it has been found that MIM cold cathode devices in particular can be used to good effect.

As stated above, such MIM devices comprise a metal-insulator-metal sandwich in which each metal layer may be of the same or different metal. With a sufficient electric potential (voltage) applied across the device, ie one metal layer being biased positively and the other negatively with respect to each other, electrons are emitted from the positively biased metal layer.

As long as the negatively biased layer is made of a relatively good conductor, its composition is not particularly critical. Of greater importance is the selection of the positively biased layer for which gold, silver, copper, tin, bismuth, cobalt, iron, iridium, nickel, lead and platinum can be employed; most preferably the metal employed for this layer is one of the first four of the above list. Other metals which might be employed include aluminium, beryllium, chromium, magnesium, manganese and zinc. Carbon and silicon are also candidates for the positively biased layer and these elements would be included in the term "metal" for the purposes of this specification.

It has been found that the cleanliness of the metal-insulator-metal layer interfaces is crucial for stable electron emission from the device.

In preferred embodiments, the MIM devices operate in practice with an electric potential between the metal layers leading to electron transport from the negatively biased layer to the positively biased layer - the device "current" (and thereafter emission from the device) through metallic microfilaments which grow *in situ* through the insulating layer. The process by which these microfilaments are made is sometimes referred to as "electro-forming" or simply "forming" and occurs in the MIM device once a threshold voltage across the device is exceeded.

Despite the electro-forming process occurring in preferred MIM devices, the current emitted by the MIM when sufficiently high voltages are applied across the device appears to include a contribution from direct field emission of electrons involving quantum mechanical tunnelling through the device from the negatively biased metal layer.

The choice of insulator layer thickness is therefore crucial to successful operation of the device; in particular, it must be sufficiently thin that the device current is large enough yet thick enough to prevent dielectric breakdown when the voltages required across the device for electron emission are applied.

Generally an insulator layer thickness of from 100 to 1,000 angstroms (Å) has been found to be useful. Preferably the thickness is at least 200Å, for example 300Å.

The thickness of the metal layers is not so critical. In general, however, the negatively biased layer can be as thick as required to conduct the necessary current whereas the positively biased layer should ideally be as thin as possible to provide maximum electron emission from the device.

A very thin metal layer may nevertheless be associated with a relatively high electrical resistance and it is expedient to ensure that the resistance of the positively biased layer, and preferably the other layer also, is sufficiently low, for example less than 40 ohms. This commonly is associated with a metal layer thickness of about 500 to 2,000 Å, for example about 1,000 Å.

In use of cold cathode methods of the invention, molecules to be the subject of the molecular process can be adsorbed on to a sufficiently cold cathode surface, for example at or (normally) below ambient temperatures that it produces a condensed layer of molecules, the thickness of which is controlled by the amount of gas (ie based on the pressure and dosing time) allowed in to the chamber. The molecular process can then proceed when the cathode voltage is turned on.

Alternatively, the method may involve a flow (or pulses) of gas molecules to be the subject of the molecular process across the surface of the cold cathode device while it is subject to, for example, ambient temperature.

The pressures at which the chamber in which the molecular processes can be conducted may vary depending on a number of factors. For example, in the first mode of operation above with condensation of molecules on the surface of the device, the process is largely unaffected by pressure overall. The pressure can generally be relatively low with gas being pumped from the chamber during the process. It is possible, however, for the processes to be operated at pressure approaching ambient pressure.

Equally, in the second mode of operation above with a flow of gas molecules across the surface of the device, a pressure range of between 5×10^{-9} mbar (the base pressure used) and 5×10^{-6} mbar (the maximum pressure for satisfactory use of a mass spectrometer to detect reaction ion products), has been found to be useful; the yield varied linearly with dosing pressure indicating that the yield is limited by the number of gas molecules striking the surface of the cathode device.

Equally, the voltage applied across the cold cathode will vary depending on the molecular process to be initiated by the method of the invention. The following table lists some typical gas-phase resonance energies for the production of the stated ion from its molecule.

TABLE

Ion/molecule	Resonance energies (eV)
$\text{Cl}^-/\text{CCl}_4, \text{CHCl}_3$	0.0-0.2
F^-/F_2	0.09
Cl^-/Cl_2	0.03; 2.5; 9.7
Br^-/Br_2	0.07; 0.5; 1.4; 3.7; 5.3; 8.5
I^-/I_2	0.05; 0.9; 2.5
H^-/H_2	3.75; 10.2; 13.9
Cl^-/HCl	0.81; 0.84
Br^-/HBr	0.28
I^-/HI	0.0
H^-/HCl	6.9; 9.2
$\text{H}^-/\text{H}_2\text{O}$	6.5; 8.6
$\text{OH}^-/\text{H}_2\text{O}$	6.4; 8.4; 11.2
$\text{HS}^-/\text{H}_2\text{S}$	2.3
$\text{H}^-/\text{H}_2\text{S}$	5.5; 8.0
$\text{S}^-/\text{H}_2\text{S}$	10.0
O^-/O_2	6.5
O^-/CO_2	4.4; 8.0
O^-/NO	8.0
O^-/CO	9.8; 11.0

It should be noted that there is considerable structure in the ion yield spectra as a function of electron energy so that more than one "peak" may be observed.

The process of the invention is in general highly tunable and the energy of electrons emitted by the cold cathode may be chosen to populate the resonance level (negative ion state) of one type of molecule present, ie adsorbed, on the surface rather than another type; another choice of electron energy can select another species. The key to the principle of operation of the method of the invention is that electrons are emitted from that surface of the cold cathode onto which the reactant molecules are in contact and adsorbed. The method can therefore operate in a relatively high pressure stream of reactant gas flow.

For a better understanding of the invention, reference will now be made for the purposes of exemplification only, to the accompanying drawings, in which:

Figure 1 is a schematic representation of a cold cathode device for use in the method of the invention.

Figure 2 is a graph of the yield of Cl^- ions desorbed from the outer surface of a cold cathode (MIM) device, on which chloroform is adsorbed, as a function of the voltage applied across the device.

Figure 3 shows, separately from the example of Figure 2, a graph of the desorbed Cl^- signal from a chloroform source signal recorded as a function of time while the device is exposed to pulses of CCl_3H gas.

With reference to the drawings, Figure 1 shows a microelectronic device for use to initiate and control a chemical reaction. It comprises a thin film metal-insulator-metal (MIM) sandwich in which the metal layers are both copper and the insulating layer is SiO_x . All the layers were produced by evaporation from resistively heated boats in ultra-high vacuum.

The cold cathode device shown in Figure 1 was employed to initiate a molecular reaction with chloroform (CCl_3H) in a reactor chamber. The chloroform was introduced into the chamber so that chloroform molecules were adsorbed onto the outer (top) surface of the device and the electron energy of the device was set (by

controlling the voltage applied across the device with the positively biased metal layer at the top) to correspond to a dissociative electron attachment (DA) resonance in the adsorbate, thereby effecting molecular dissociation represented by:



The cross section for this process shows well defined resonances at specific energies corresponding to affinity levels of the target molecule into which the incident electron is injected.

Figure 2 shows the yield of Cl^- ions desorbed from the outer surface of a metal-insulator-metal (MIM) device on which chloroform, CCl_3H , is adsorbed by exposing the device to a pressure of 10^{-8} mbar of CCl_3H gas admitted to the vacuum chamber housing the device for fifty seconds (an exposure of 0.5 Langmuirs), as a function of the voltage applied across the device. The desorbed ions are detected with a pulse counting mass spectrometer. Also plotted is the current of electrons emitted from the device. It is evident from figure 2:

(a) that the weakly adsorbed CCl_3H is dissociated by the device, and

(b) that dissociation arises from the emission of electrons from the device, as witnessed by the similar voltage thresholds for electron emission and ion desorption. Since the voltage is set via a computer interface, this is in effect a "voltage-controlled catalyst" programmed by a computer.

Figure 3 gives another example of the device in operation; here pulses of CCl_3H gas are let into the vacuum chamber housing the device, and the desorbed Cl^- signal is recorded as a function of time while the device is running under steady operating conditions. The molecular dissociation signal clearly tracks the admitted gas pressure, showing that under these conditions the operation of the device is gas flux limited rather than emission current limited.

Claims

1. A method for effecting the initiation of a molecular process or reaction in a substance, which comprises bringing the substance into contact with a surface of a cold cathode device and applying an electric potential across the cold cathode device to cause electrons to be emitted from the surface thereof with an energy level sufficient to effect the initiation.
2. A method according to Claim 1 in which the cold cathode is a metal-insulator-metal (MIM) device.
3. A method according to Claim 2 in which the insulator layer of the MIM device has a thickness of from 100 to 1000 angstroms.
4. A method according to Claim 3 in which the insulator layer of the MIM device has a thickness of at least 200 angstroms.
5. A method according to any one of Claims 2 to 4 in which the electrical resistance of the positively biased layer is less than 40 ohms.
6. A method according to any one of Claims 2 to 5 in which the metal layers of the MIM device are both copper and the insulating layer is a silicon oxide (SiO_2).
7. A method according to any one of Claims 2 to 6 which initiates a molecular reaction with chloroform (CCl_3H).

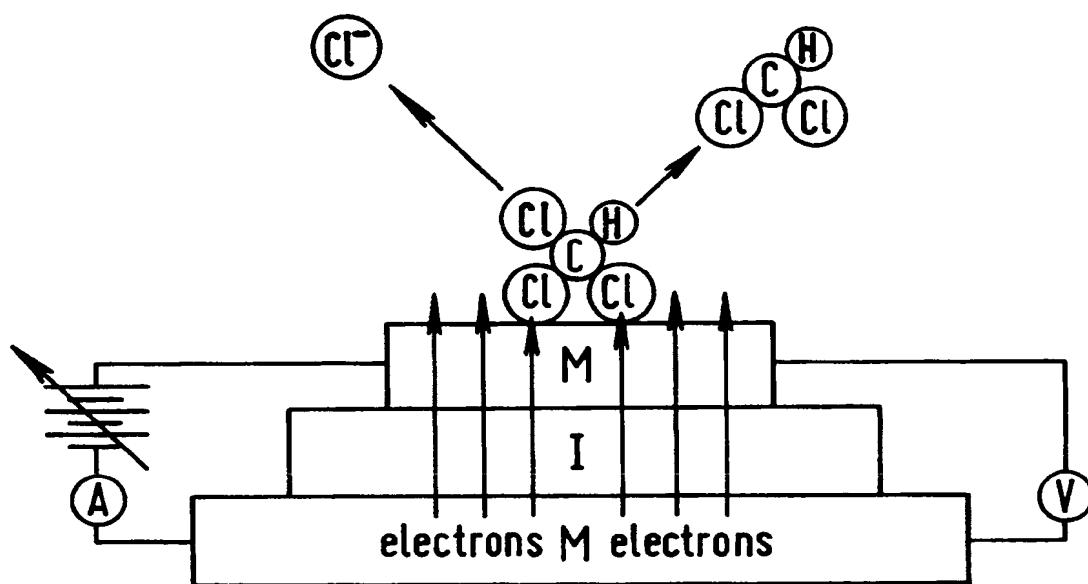


FIG. 1.

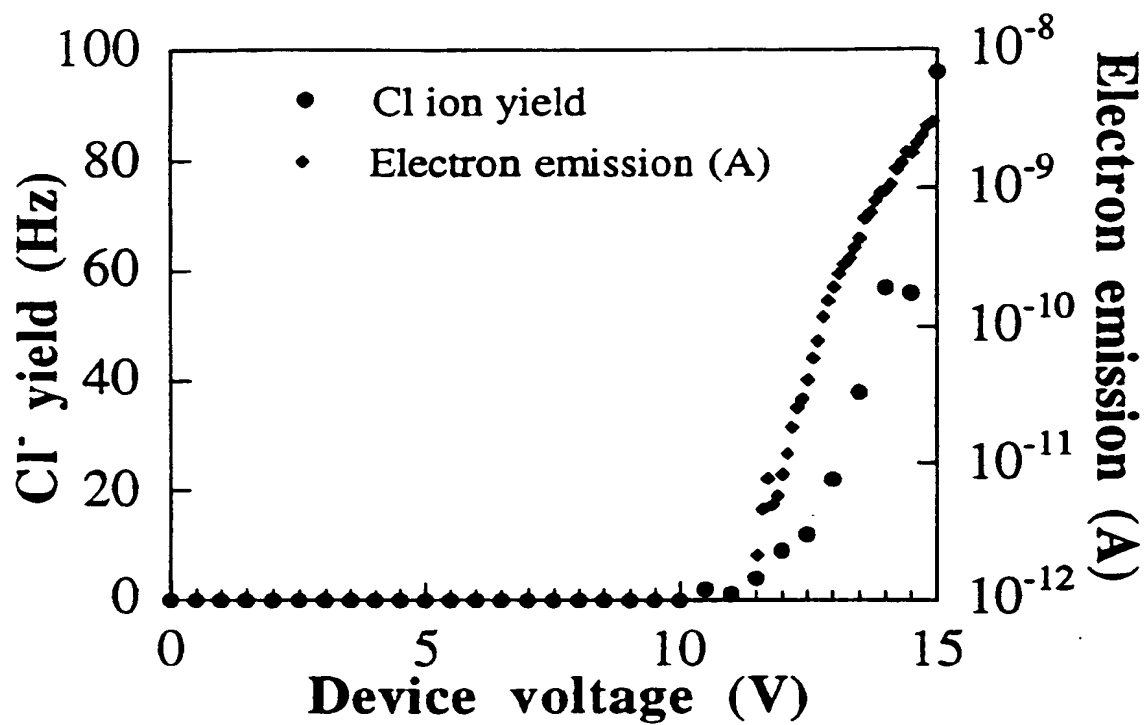


FIG. 2.

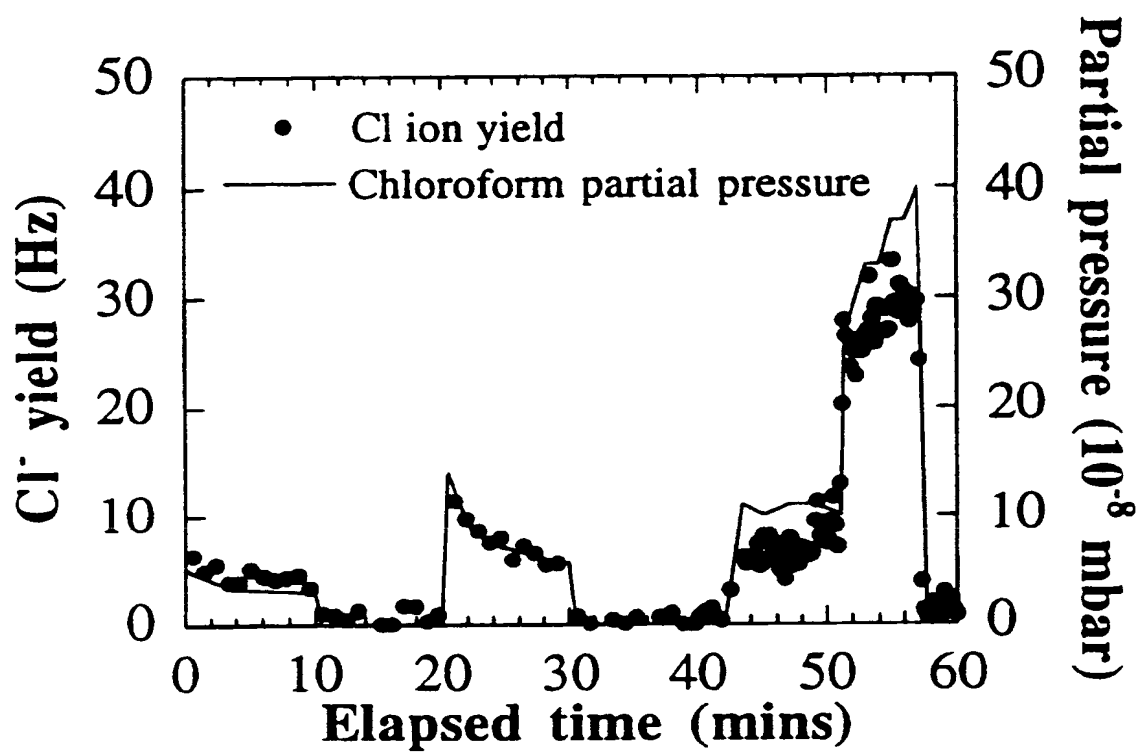


FIG. 3.



European Patent
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EUROPEAN SEARCH REPORT

Application Number
EP 94 30 6029

DOCUMENTS CONSIDERED TO BE RELEVANT			
Category	Citation of document with indication, where appropriate, of relevant passages	Relevant to claim	CLASSIFICATION OF THE APPLICATION (Int.Cl.6)
X	WO-A-89 02868 (SACKINGER) * page 3, paragraph 2 - page 4, paragraph 1; claims; figures * * page 8, paragraph 1 - page 10 *	1	B01J19/08 C07C17/23
A	US-A-3 836 786 (LOWTHER) * figures 1,2 *	1,2	
A	US-A-3 772 172 (VACHAGANOVITCH ET AL)	1	
A	US-A-4 204 926 (MEYER)	1	
A	US-A-3 359 466 (POLLACK ET AL)	2-6	
A	US-A-5 019 530 (KLEINSASSER)	2-6	
			TECHNICAL FIELDS SEARCHED (Int.Cl.6)
			B01J C07C H01L
The present search report has been drawn up for all claims			
Place of search THE HAGUE		Date of completion of the search 15 November 1994	Examiner Meertens, J
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